INFORMATION DISCLOSURE STATEMENT TRANSMITTAL

To Commissioner For Patents

Enclosed herewith is a Form PTO-1449, any required copies of documents listed thereon, and any concise explanation of their relevance is indicated below per 37 CFR 1.97.

Application Number	10/562293		
Filing Date	12.22.05		
First Named Inventor	GREEN, PETER W.		
Group Art Unit	2823		
Examiner Name	N. Tobeste		
Atty. Docket Number	GB02 0136 US		

			U.S. P/	ATENT DOCUMENTS	
Examiner Initials*	Cite No.	Document Number NoKind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns Lines, Where Relevant Passages or Relevant Figures Appear
79	1	us- 5 130 829	07/14/1992	SHANNON JOHN M.	
M	2	us- 5 340 758	08/23/1994	WEI, CHING-YEU	
		₩6			
		US-			
		US			
		US-			

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.'	Document Number (ctry ³ -no. ⁴ -kind ⁵ , if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of caed document	Pages, Columns Lines, Where Relevant Passages or Relevant Figures Appear	т
N	1	JP 11 004001	01/06/1999			
NA	2	WO 02/091475 A1	11/14/2002	DEANE STEVEN C. ET AL.		

	,	NON-PATENT LITERATURE DOCUMENTS	: :
Examiner Initials*	Cite No.1	include name of the author (in capital letters), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ⁰
NT	1	YASUTAKA UCHIDA ET AL: "VERTICAL-TYPE AMORPHOUS-SILICON FIELD-EFFECT TRANSISTORS WITH SMALL PARASITIC ELEMENTS"; JAPANESE JOURNAL OF APPLIED PHYSICS; TOKYO, JAPAN; Sept. 9th, 1986; pages 798-800	
M	2	MASAKIYO MATSUMURA ET AL.: "AMORPHOUS-SILICON THIN-FILM TRANSISTORS MATCHED TO ULTRA-LARGE PANELS; MATERIALS RESEARCH SOCIETY; TOKYO, JAPAN; Vol. 467; 1997; pages 821-829	
M	3	700 IBM TECHNICAL DISCLOSURE BULLETIN 29 (1986); OCT. No. 5; NY USA	

Examiner	Date .	12 /10/06
Signature	Considered	12/18/06

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the